



03500.010530.5

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
Kiyofumi SAKAGUCHI, et al.	)	Examiner: George R. Fourson, III
Appln. No.: 10/085,046	)	Group Art Unit: 2823
Filed: March 1, 2002	)	
For: PROCESS FOR PRODUCTION OF	)	
SEMICONDUCTOR SUBSTRATE	)	November 14, 2005

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

REMARKS

The following documents were cited in a Japanese Official Action of a foreign counterpart application (Japanese Patent Application No. 10-230926) corresponding to the above-referenced application:

- (1) JP-A 05-021338;
- (2) JP-A 05-211128;

- (3) JP-A 05-218464;
- (4) JP-A 05-283722;
- (5) JP-A 05-217827
- (6) JP-A 05-299362; and
- (7) JP-A 04-034961.

English-language Abstracts for Documents (1), (3), (6), and (7) were obtained from a commercial database and are also enclosed. Documents (2) and (4) were cited in the September 5, 2002 Information Disclosure Statement, and Document (5) was cited in the October 21, 2003 Information Disclosure Statement. The Japanese Official Action is dated October 11, 2005. A copy of the Japanese Official Action is also enclosed.

#### FORMAL MATTERS

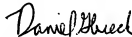
Any fee required in connection with this paper should be charged to Deposit Account No. 06-1205.

#### CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /GF/